

QCO.091A



PATENT

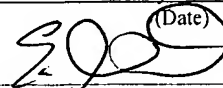
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wen-Jian Lin
Appl. No. : 10/810,660
Filed : March 29, 2004
For : STRUCTURE OF A MICRO
ELECTRO MECHANICAL
SYSTEM AND THE
MANUFACTURING METHOD
THEREOF
Examiner : Jarrett J. Stark
Group Art Unit : 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 2, 2006

(Date)


Eric M. Nelson, Reg. No. 43,829

AMENDMENT

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed February 2, 2006, please find the enclosed amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.